

Nano4me.org Video Download

ESC 212: Basic Nanotechnology Processes

Unit 2: An Introduction to Uses of Plasmas in Processing



Lecture 2

Length: 47:02

This video will cover:

- Sputtering as an Additive Process
- Examples of Systems
- Process Applications

Thank You For Watching!

What did you think? [Email](#) Bob Ehrmann with your feedback.

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